

**CERTIFICATE OF ELECTRONIC  
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I hereby certify that this correspondence for Application No. 10/524,525 is being electronically transmitted to Technology Center 1765, via EFS-WEB, on July 13, 2007.

<u>/David H. Brinkman/</u>	<u>7/13/07</u>
David H. Brinkman, Reg. No. 40,532	Date

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s):	Martin Hausner
Serial No.:	10/524,525
Filed:	August 18, 2005
Confirmation No.:	1134
Group Art Unit:	1765
Examiner:	Ahmed, Shamim
Title:	<b>METHOD FOR SELECTIVELY REMOVING MATERIAL FROM THE SURFACE OF A SUBSTRATE, MASKING MATERIAL FOR A WAFER, AND WAFER WITH MASKING MATERIAL</b>
Atty. Docket:	BEET-09

Cincinnati, Ohio 45202

July 13, 2007

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

In response to the Office Action mailed on April 13, 2007, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Amendments to the Abstract** begin on page 12 of this paper.

**Remarks/Arguments** begin on page 13 of this paper.